YOUNGJIN KIM

PhD Candidate

Seoul National University, Seoul, South Korea

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EDUCATION

B.S. Electrical and Computer Engineering 2012. 3 – 2019. 2

Seoul National University, Seoul, Republic of Korea

Advisor: Byung Gook Park (deceased)

M.S. - Ph.D. Electrical and Computer Engineering 2019.3 – 2025. 2

Seoul National University, Seoul, Republic of Korea

Former advisor: Byoungho Lee (deceased)

Current advisor: Yoonchan Jeong (yoonchan@snu.ac.kr)

PROFESSIONAL EXPERIENCE

Visiting Researcher Stanford University, CA, USA

2023. 12 - 2024. 2

- Professor: Mark Brongersma, Department of Materials Science and Engineering

Research Scientist Intern Meta Reality Labs, WA, USA

2024. 6 - 2024. 10

- Department: Optics & Display Research
- Research subject: New waveguide architecture development

RESEARCH EXPERIENCE

- Metasurfaces / Nano-optics
 - Physical understanding of nanostructures' optical response
 - Metasurfaces / Nano-optics design using near-field and far-field simulations
 - Hands-on nanofabrication using lithography-techniques
- Metasurface folded optics (Waveguide)
 - Waveguide-type folded metasurface system design using ray-tracing or wave-optics simulations for ultraslim and integrated imaging system
 - Hands-on wafer double-side nanofabrication using lithography-techniques
- Computational design of optical systems leveraging metasurface optics
 - Joint optimization of metasurface and spatial light modulator (SLM) phase profiles
 - End-to-end optimization of metalens imaging system (Hardware + Software co-design)

- Metasurface proxy model design for fully differentiable optimization framework
- Metagrating optimization through rigorous coupled-wave analysis using automatic differentiation
- Application to Cameras / AR,VR systems / Holographic display / Microscopy

HONOR AND AWARDS

- Distinguished Dissertation Award
 - Seoul National University, 2025.
- Seoul National University Joint International Research Grant Seoul National University, 2023.
- Silver Prize, Samsung Display Industry-Academia Technical Paper Awards
 Samsung Display, 2023.
- Scholarship of Foundation for SNU ECE Kim Jung Sik Fund Seoul National University, 2021.
- Best Poster Paper Awards
 Optics and Photonics Congress, Jeju, South Korea, 2021.

JOURNAL PUBLICATIONS

First Author (4)

† : equal contribution

- 1. Y. Kim[†], T. Choi[†], G.-Y. Lee, C. Kim, J. Bang, J. Jang, Y. Jeong, and B. Lee, "Metasurface Folded Lens System for Ultrathin Cameras," Science Advances, vol. 10, no. 44, pp. eadr2319, 2024.
- 2. S.-W. Nam[†], Y. Kim[†], D. Kim, and Y. Jeong, "<u>Depolarized Holography with Polarization-multiplexing Metasurface</u>," ACM Transactions on Graphics (SIGGRAPH Asia), vol. 42, no. 6, article 200, 2023. (Top 5% in Computer Graphics)
- 3. Y. Kim, G.-Y. Lee, J. Sung, J. Jang, and B. Lee, "Spiral Metalens for Phase Contrast Imaging," Advanced Functional Materials, vol. 32, no. 5, pp. 2106050, 2022.
- 4. Y. Park[†], Y. Kim[†], C. Kim, G.-Y. Lee, H. Choi, T. Choi, Y. Jeong, and B. Lee, "End-to-end Optimization of Metalens for Broadband and Wide-angle Imaging," **Advanced Optical Materials**, 2025. (Accepted)

JOURNAL PUBLICATIONS

Co-Author (6)

- 1. S.-J. Kim, C. Kim, Y. Kim, J. Jeong, S. Choi, W. Han, J. Kim, and B. Lee, "<u>Dielectric metalens: properties and three-dimensional imaging applications</u>," **Sensors**, vol. 21, no. 13, pp. 4584, 2021.
- J. Jang, G.-Y. Lee, <u>Y. Kim</u>, C. Kim, Y. Jeong, and B. Lee, "<u>Dispersion-Engineered Metasurface Doublet Design for Broadband and Wide-Angle Operation in the Visible Range</u>," <u>IEEE Photonics Journal</u>, vol. 15, no. 4, pp. 1-9, 2023.
- 3. C. Kim, J. Hong, J. Jang, G.-Y. Lee, <u>Y. Kim</u>, Y. Jeong, and B. Lee, "<u>Freeform Metasurface Color Router for Deep Sub-micron Pixel Image Sensors</u>," **Science Advances**, vol. 10, no. 22, pp. eadn9000, 2024.

- H. Son, T. Choi, K. Kim, Y. Kim, J. Bang, S.-J. Kim, B. Lee, and Y. Jeong, "Strong Coupling Induced Bound States in the Continuum in a Hybrid Metal-Dielectric Bilayer Nanograting Resonator," ACS Photonics, vol. 11, no. 8, pp. 3221-3232, 2024.
- T. Choi, C. Choi, J. Bang, Y. Kim, H. Son, C. Kim, J. Jang, Y. Jeong, and B. Lee, "Multiwavelength Achromatic Deflector in the Visible Using a Single-Layer Freeform Metasurface," Nano Letters, vol. 24, no. 35, pp. 10980-10986, 2024.
- E. Lee, Y. Jo, S.-W. Nam, M. Chae, C. Chun, Y. Kim, Y. Jeong, and B. Lee, "Speckle Reduced Holographic Display System with a Jointly Optimized Rotating Phase Mask," Optics Letters, vol. 49, no. 19, pp. 5659-5662, 2024.

CONFERENCES First Author (5)

- 1. <u>Y. Kim</u>, C. Kim, B. Lee, Y. Jeong, and B. Lee, "Meta-optic Miniaturized Telephoto Lens System," High Contrast Metastructures XII, SPIE Photonics West 2023, San Francisco, USA, paper 12432-32, Feb. 2023. (Oral presentation)
- 2. <u>Y. Kim</u>, C. Kim, and B. Lee, "Phase contrast imaging with multiwavelength achromatic spiral metalens," OSA Optical Design and Fabrication Congress, Virtual Conference, paper FW4C.3, Jun. 2021. (Oral presentation)
- 3. <u>Y. Kim</u>, J. Hong, and B. Lee, "Edge detection metalens with additional spiral phase profiles," The 20th International Meeting on Information Display (IMID 2020), Virtual Conference, paper 04-10-1232, Aug. 2020. (Oral presentation)
- 4. Y. Kim, C. Kim, and B. Lee, "Single-layer edge detecting metalens with combining hyperbolic and spiral phase profiles," The 14th Pacific Rim Conference on Lasers and Electro-Optics (CLEO PR 2020), Virtual Conference, paper P5-7, Aug. 2020.
- Y. Kim, J. Hong, J. Sung, and B. Lee, "Transmission-Type Color Filters with Silicon Mie Resonators using Guided-Mode-Resonance," OSA Frontiers in Optics + Laser Science APS/DLS, Washington D.C., USA, paper JW4A.74, Sep. 2019.

PATENTS

- Y. Park, <u>Y. Kim</u>, G.-Y. Lee, B. Lee, Y. Jeong, "Double sided metalens and electronic device including the same" (US – Application No. 18/490,121)
- 2. Y. Jeong, S.-W. Nam, <u>Y. Kim</u>, D. Kim, "Holographic display using metasurface and metasurface optimization method" (US Application No. 18/737,648)

SKILLS

Numerical simulations

Optical near-field simulations:

RCWA (Python, Pytorch), FEM (COMSOL Multiphysics), FDTD (Lumerical)

Optical far-field simulations:

Ray-optic simulation (Zemax), Wave-optic simulation (MATLAB, Python, Pytorch)

Computational optics design:

Data-driven optimization through machine-learning framework (Pytorch), Inverse design of periodic nanostructures using automatic-differentiation (Pytorch)

Programming languages & tools:

MATLAB, Python (Pytorch), ZPL (for Zemax)

Experimental experiences

Optical microscopy, Photography, Holographic display with spatial light

modulator, Laser/LED-based experiments

Device fabrication Nanofabrication:

Focused ion beam (FIB) milling, Electron beam lithography, Photolithography (Aligner, Maskless lithography), Electron beam evaporator, Plasma-enhanced chemical vapor deposition (PECVD), Reactive ion etching (RIE)

Measurement:

Scanning electron microscope (SEM), Ellipsometry

Languages Korean (Native) / English (Fluent)

RESEARCH EXPERIENCE - Projects

• Metalens planar optic system for ultra-slim camera module

Researcher, Samsung Science & Technology Foundation Jun. 2020 – July. 2023

• Improvement of µLED optical characteristics using metasurface technology.

Researcher, Samsung Display March. 2021 – Feb. 2023

• Research for integrated meta-photonics system and its application to mobile real-time 3D imaging

Researcher, National Research Foundation of Korea

Mar. 2020 - November. 2022

Development of virtual reality technology using metasurface optics

Researcher, Samsung Display March. 2020 – Feb. 2021